



IFW

Docket No.: 050389-0052

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 20277  
Chihiro KAWAI, et al. : Confirmation Number: 3373  
Application No.: 10/500,975 : Group Art Unit: 2811  
Filed: July 08, 2004 : Examiner: Arena, Andrew Owens

For: POROUS SEMICONDUCTOR AND METHOD FOR MANUFACTURING SAME

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action  
dated August 9, 2006.